

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE

APPLICATION OF: DIMITRI LEDERER ET AL.

SERIAL NO.: 10/572,799

CONFIRMATION NO. 4919

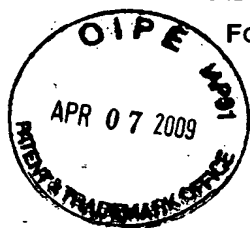
GROUP ART UNIT: 2891

FILED: March 22, 2006

EXAMINER: Julia Slutsker

FOR: METHOD OF MANUFACTURING A
MULTILAYER SEMICONDUCTOR
STRUCTURE WITH REDUCED
OHMIC LOSSES

ATTY. REFERENCE: LEDE3001/JJC/JDG



PETITION FOR EXTENSION OF TIME

COMMISSIONER FOR PATENTS

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136 (a) for:

☐ One Month

☐ Three Months

☒ Two Months

☐ Four Months

☐ Five Months

The fee set in 37 CFR 1.17 for the extension of time is **\$245.00**

☒ Fee enclosed. Please charge any additional fee required for this extension of time to **Deposit Account Number 02-0200**.

☐ Charge fee to **Deposit Account Number 02-0200**. A duplicate copy of this paper is enclosed.

☒ Applicant is a **small entity** entitled to pay reduced fees in this application.

Also enclosed is a:

☒ Amendment and Reply to Office Action of November 7, 2008

23364

Customer Number

Phone: (703) 683-0500

Respectfully submitted,

DATE: April 7, 2009

RICHARD E. FICHTER

Attorney for Applicant

Registration Number: 26,382

04/09/2009 LLANDGRA 00000002 10572799

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